

RECEIVED  
CENTRAL FAX CENTER  
JAN 17 2006

Docket No.: 83217US1  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Richard F Fernsler et al.

Application No.: 10/672,269

Confirmation No.: 8821

Filed: September 26, 2003

Art Unit: 1763

For: Method and apparatus for producing an ion-ion  
plasma continuous in time

Examiner: R. R. Bucker

**AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Entered with RCE 2/14/16  
MW 2/23/16

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated December 22, 2005, finally rejecting claims 1-8, and 14-16, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.